

DOCKET NO.: 263878US2PCT/sal

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF:

Kenji FUKUDA, et al.

GROUP: 2812

SERIAL NO: 10/517,772

FILED: July 12, 2005

EXAMINER: LINDSAY JR, WALTER LEE

FOR: SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD

**SUBMISSION OF SUPPLEMENTAL APPLICATION DATA SHEET**

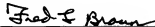
Office of Initial Patent Examination  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant(s) submit herewith a Supplemental Application Data Sheet for the above-identified application for the purpose of correcting the inventors' cities of residence and their mailing addresses.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.



Marvin J. Spivak  
Registration No. 24,913

**Fred L. Braun**  
**Registration No. 56,123**

Customer Number

**22850**

Tel. (703) 413-3000  
Fax. (703) 413-2220  
(OSMMN 06/04)